


First Named Inventor	Zhongze Wang	REPLY UNDER 37 C.F.R. §1.116 - EXPEDITED PROCEDURE - TECHNOLOGY CENTER 2800 
Serial No.	10/758,059	
Filing Date	January 15, 2004	
Group Art Unit	2823	
Examiner Name	Thanh V. Pham	
Confirmation No.	5110	
Attorney Docket No.	400.147US02	
Title: FET HAVING EPITAXIAL SILICON GROWTH		

Mail Stop: AF
 Commissioner for Patents
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In response to the Final Office Action mailed April 4, 2006, please consider the
 following:

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